

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/609,291	JACKSON ET AL.	
Examiner	Art Unit	
Harold Kim	2181	

	SEARCHED		
Class	Subclass	Date	Examiner
710	52,27,29	5/11/2006	нк
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INT	ITERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH		
	DATE	EXMR
USPAT, USPGPUB, JPO, EPO, IEEE, NPL, see attached search note; inventor search on dDAN	5/11/2006	НК
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Anold & 5/11/2006